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The phase, morphology and surface characterization of Ti–Mo alloy films prepared by magnetron sputtering

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Magnetron sputtering is a physical vapor deposition process which allows the formation of metastable materials because of the particle bombardment process. Ti–Mo alloys are typical biomedical β -Ti alloys because of the remarkable β -stabilizing effect and the favorable safety of the Mo element. In this paper, Ti–15 wt% Mo and Ti–30 wt% Mo alloy films prepared by magnetron sputtering are studied. The substrate temperatures are 50 °C, 100 °C, 200 °C and 300 °C, respectively, which are far below the β -transus temperatures of Ti–Mo alloys. The two films both show metastable β -Ti growth at 50 °C and 100 °C, but have different phase evolutions as the substrate temperature further rises. The diversity is attributed to the different stabilities of metastable β growth in the two films. The different morphology evolutions with the increasing substrate temperature between the two films are discussed. The natural surface oxidation layers of the two films are analyzed by XPS.

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1. Introduction

Titanium (Ti) and its alloys offer a wide range of adaptable structures for biomedical applications.¹ Interest in β -Ti alloys as biomaterials was derived from the excellent combination of good mechanical properties with low elastic modulus (E) close to that of human bone ($E = 10\text{--}40$ GPa (ref. 2 and 3)), leading to better bone remodeling and osseointegration processes compared with α - and $\alpha + \beta$ -Ti alloys.⁴ It is known that the properties of β -Ti alloys are greatly affected by alloying elements. On one hand, solid-solution strengthening is the most important strengthening mechanisms involved in these alloys. On the other hand, by the addition of enough β stabilizing elements (Mo, Nb, V, Fe, Ta, *etc.*), metastable β -Ti alloys can be produced by the fast cooling process following the heating treatment above T_β (β transus temperature). A series of β -Ti alloys have been developed, such as Ti–Mo,^{5–12} Ti–Nb,¹³ Ti–Mo–Nb,¹⁴ and Ti–Nb–Zr–Fe (Ta).¹⁵ Among these alloys, metastable Ti–Mo alloys receive much attention because of the remarkable β -stabilizing effect and the favorable safety of the Mo element. According to Bania *et al.*,⁷ only 10 wt% of Mo content is needed to fully stabilize the β phase at room temperature in a quenched Ti–Mo alloy. Ho *et al.*⁵ found that the cast binary Ti–(10–20) wt% Mo alloys show metastable β -Ti growth, while those with less than 10 wt% Mo content exhibit a martensitic transformation from the β phase to orthorhombic α'' or hexagonal α' phase.

Magnetron sputtering of thin films has developed into a mature field of physical vapor deposition (PVD) technologies. The relations between deposition parameters and film structures are of fundamental importance because understanding these relations helps to control the film growth.^{16–23} During the sputtering process, the atom configurations on the substrate are essentially depend on two parameters: (i) the ratio T_s/T_m which controls the conventional heating process, in which T_s and T_m are the substrate temperature and the melting temperature of deposited materials, respectively, and (ii) the energy delivered to growing surface of the film by particle bombardment (atomic scale heating), which is related to the deposition conditions, such as working pressure, substrate bias or sputtering power.^{24–26} It is necessary to note that the atomic scale heating stimulates highly non-equilibrium cooling processes which results in the formation of metastable and unstable materials. This is one of the main reasons for the formation of special structures of the films under particle bombardment.

According to conventional heating processes, it is reasonable to affirm that β -Ti phase would be formed in Ti alloy films when they are deposited above T_β . However, in practical cases, the deposition above T_β is seldom used because of two issues. One is the interface reaction between the film and the substrate at such high T_s , the other is a subsequent stabilization of β -Ti phase to low temperatures when cooled down. To the best of our knowledge, Musil *et al.*²⁷ firstly reported the formation of metastable β -Ti alloy films formed by magnetron sputtering. Because of atomic scale heating from particle bombardment, β -type Ti–10 wt% Cr and Ti–10 wt% Fe films can be formed when T_s is below 100 °C ($T_{\beta,\text{Ti–Cr}} \geq 667$ °C,²⁷ $T_{\beta,\text{Ti–Fe}} \geq 595$ °C (ref. 28)). Regent *et al.*²⁹ reported the same result for Ti–10 at% Mo alloy

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films on a unheated substrate. These results show a feasible way to form metastable β -Ti alloy films at a low T_s ($T_s < T_\beta$), which avoids the two issues mentioned above. However, it gives rise to another two problems. The first is the formation of β -Ti determined by particle bombardment on the growing surface of the films during deposition. Enough bombardments are desired to provide a sufficient energy for the adatoms to form high temperature β phase at the low T_s range, while too much bombardments cause interface local heating, implantation, vacancy or disruption of crystallizations in the films. For instance, from XRD results, Ti-10 wt% Cr alloy films have a α -Ti growth without substrate bias, but change into an amorphous growth at -150 V.²³ Also, they could have a β -Ti growth when under proper bombardment conditions.²⁷ The second problem is to keep the metastable β -Ti phase in the films during the whole deposition, which depends on alloy composition of the films and the T_s . Substrate heating could partly decrease defects, and improve film/substrate interface bonding, crystallinity or structural density of the films, but it may cause the decomposing of metastable β -Ti phase during the deposition.³⁰ Therefore, the stability of metastable β -Ti phase in the sputter-deposited films needs to be investigated. This work is mainly devoted to the second problem.

In the biomedical field, however, magnetron sputtering is still a novel technique. Nanostructural surfaces of biomedical Ti alloys are interesting when it comes to the bone/Ti alloy implant interfaces. The high surface energy of nanomaterials leads to desirable cellular responses and high osseointegration.³¹ Ivanova *et al.*³² studied the bioactivity of Ti films with different thickness (3, 12, or 150 nm), and revealed a direct link between the nanoscale surface roughness and cell attachment of the films. More recently, β -Ti alloy films have attracted more attentions because of enhanced biomedical properties of β -Ti alloys compared with α - or $\alpha + \beta$ -Ti alloys. Coating of less biocompatible materials with β -Ti alloy films has become an alternative way to improve the biomedical properties.^{33,34} For instance, Tallarico *et al.*³⁴ prepared biomedical β -type Ti-Nb-Zr alloy coatings on stainless steels by magnetron sputtering, and investigated the growth and surface chemistry of the coatings. Gonzalez *et al.*³³ studied the morphology, microstructure and compositions of biomedical β -type Ti-Nb alloy films deposited at 200 °C, with 15 at%, 20 at%, 30 at% and 40 at% Nb content, respectively. Besides these biomedical applications, β -Ti alloy films can also serve as hydrogen storage materials because hydrogen has a high solubility in β -Ti alloys. Shi *et al.*^{35,36} showed that Ti-Mo alloy films have an improvement in hydrogen storage capacities compared to pure Ti films, and the resistance against embrittlement of the films was enhanced because of the ductility of β -Ti phase and the reduction of the hydrogenise formation. Magnetron sputtering allows the production of metastable β -Ti alloy films, therefore, it is now prompting new researches for those applications. Controlling the metastable β -Ti growth in the films is primarily important, however, very complex, because it is highly related to several conditions, such as T_s , particle bombardment and the compositions of the films. Understanding these is necessary for

determining preparation parameters, film compositions, and service temperatures of the films in practical applications.

Ti-15 wt% Mo and Ti-30 wt% Mo alloys are both popular biomedical Ti-Mo alloys,^{6,37} however, their as-sputtered structures have yet not been studied. In the present work, Ti-15 wt% Mo and Ti-30 wt% Mo alloy films formed by magnetron sputtering technique are investigated, respectively, with main concerns on phase, morphology and surface characterization of the films. T_β of pure Ti is 882 °C and the approximate amount of β transus reduction per wt% of Mo addition is about 8.3 °C. Therefore, T_β of Ti-15Mo and Ti-30Mo can be estimated as 758 °C and 633 °C, respectively.³⁸ The T_s during deposition is 50 °C, 100 °C, 200 °C and 300 °C, respectively. The metastable β -Ti growth of the two films are obtained at 50 °C and 100 °C, but they show different phase evolutions as the T_s further rises, which is attributed to the different stability of metastable β -Ti phase. Accordingly, the different morphology evolutions in the T_s range between the two films are shown and discussed, respectively. Besides, surface characterization is an important topic of biomedical materials because it plays a key role in the living tissue response to the metal presence. Considering that Ti and Mo elements are both chemically reactive, nature surface oxidation layers of the films are analyzed using X-ray photoelectron spectroscopy (XPS).

2. Experimental

We deposited the Ti-Mo alloy films on silicon (Si) (100) substrates by direct current magnetron sputtering. The alloy targets of two compositions were used: Ti-15 wt% Mo and Ti-30 wt% Mo, which were prepared by melting appropriate amounts of Ti and Mo powders. Hereafter, Ti-15 wt% Mo and Ti-30 wt% Mo will be simplified as Ti-15Mo and Ti-30Mo. We used high-purity (99.999%) argon as the sputtering gas. The base pressure was 5.0×10^{-4} Pa and the sputtering pressure was 0.8 Pa. Before starting the actual deposition, we pre-sputtered the target for 20 min with a shutter covering the substrate. The actual deposition time of the films was 120 min. The target-substrate separation was kept at 40 mm. The sputtering power was 180 W. The substrate temperatures were 50 °C, 100 °C, 200 °C, and 300 °C, respectively. Three samples were prepared for each condition. After each deposition, we kept the T_s for 20 min and then we cooled the films to room temperature in the vacuum.

We analyzed phase, texture, morphologies of the films using X-ray diffraction (XRD) operated on PANalytical X'Pert PRO MPD instrument (Almelo, Netherlands), Tescan MIRA3 XMU scanning electron microscope (SEM; Brno, Czech Republic), and FEI Tecnai™ F30 G2 transmission electron microscope (TEM; Hillsboro, OR) with accelerating voltage of 300 kV, respectively. Surface roughness of the films were measured using Shimadzu SPM-9600 atomic force microscope (AFM; Kyoto, Japan). The instrument was operated in the contact mode, and the measuring range was $5 \times 5 \mu\text{m}^2$. Bulk compositions of the films were detected by a SEM-based INCA energy dispersive spectrometer (EDX) with an X-MAX detector (Oxford Instruments, UK). The calibration was performed using a Ti standard, and



the quantization was processed with a built-in XPP correction procedure. Surface chemical compositions of the films were analyzed using Thermo Fisher X-ray photoelectron spectroscopy (XPS; America) with a Al K α ($h\nu = 1486.6$ eV) monochromatized focused X-ray source. The spectrometer was calibrated against the reference binding energies (BEs) of clean Cu (Cu 2p $_{3/2}$ at 932.6 eV), Au (Au 4f $_{7/2}$ at 84.0 eV) and Ag (Ag 3d $_{5/2}$ at 368.2 eV). The analyzed area is $400 \times 400 \mu\text{m}^2$. In addition to the survey spectrum (pass energy of 200 eV, step energy of 1 eV), the following core levels were systematically recorded at higher energy resolution (pass energy of 50 eV, step energy of 0.1 eV): C 1s, O 1s, Ti 2p, Mo 3d. The binding energy positions were determined through curve fitting with the mixed 30% Lorentzian and 70% Gaussian curves and Shirley baselines using the Advantage software. Core levels were calibrated by the standard C 1s peak at 284.8 eV.

3. Results and discussion

Fig. 1(a) shows typical XRD patterns of the Ti–15Mo alloy films at different T_s . It can be seen that (i) the Ti–15Mo alloy films have a metastable β growth at 50 °C and 100 °C, and (ii) the orthorhombic α'' phase was formed at a higher T_s . Fig. 1(b) shows close up of the reflections from 36° to 41°, in which a single $\beta(110)$ peak is observed below 100 °C, and a composition of $\beta(110)$ and $\alpha''(111)$ peaks appears at higher T_s . The (110) plane is the densest plane of β -Ti phase which has a body-centred cubic structure. Increasing the T_s is supposed to help the (110) growth of the film because of the reduced surface energy of the film.³⁹ However, the $\beta(110)$ peak is decreased as the T_s rises in this work, which is also found in our previous

work for Ti–5Al–4Mo–4Cr–2Zr–2Sn alloy films.³⁰ This is because, with the occurrence of the phase evolution, the growth of the film is determined by a combined effect of the reduced surface energy of the film and the interfacial energy between different phases. The α'' phase is a well-known transition phase during the transformation from β -Ti to α -Ti. The formation of α'' phase indicates that the metastable β -Ti phase has changed because of the activation energy provided by heating substrate above 100 °C. Therefore, in Ti–15Mo alloy films, a sufficiently low T_s (no more than 100 °C) is necessary to stabilize the metastable β -Ti phase during the whole deposition. We can also infer that metastable β -type Ti–15Mo alloy films can not be subjected to an excessive service temperature, such as the hydrogenation temperature in hydro-treating,³⁶ to prevent the decomposing of β -Ti phase. Fig. 2(a) shows the bright field (BF) image and the selected area electron diffraction (SAED) pattern of the Ti–15Mo film at 100 °C. The pattern further confirms the β -Ti growth of the film at this temperature because the four rings correspond to (110), (200), (211) and (220) reflections of β -Ti. The polycrystalline orientation of the crystallites shows the adatom diffusion is negative at 100 °C, so the crystallization follows the random orientations of nuclei.⁴⁰ The formation of β phase suggests that the particle bombardment conditions provide a sufficient energy for the adatoms to form the high-temperature β phase. The fast dissipation of this energy in close proximity of every incident atom results in extremely fast cooling and freezing of the β -Ti phase on the growing surface of the films during the deposition.

Fig. 1(c) shows typical XRD patterns of the Ti–30Mo alloy films at different T_s . The films could keep a β -type growth in the whole T_s range. This result shows that (i) the stability of

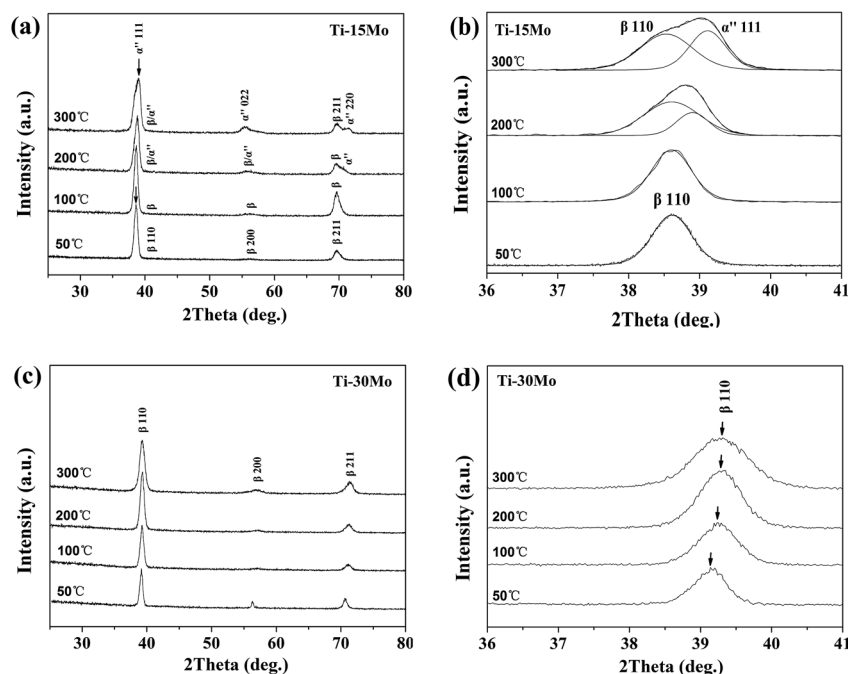


Fig. 1 The XRD patterns of the Ti–15 wt% Mo and Ti–30 wt% Mo alloy films at different T_s : (a, c) the whole patterns; (b, d) the close up from 36° to 41°, respectively.



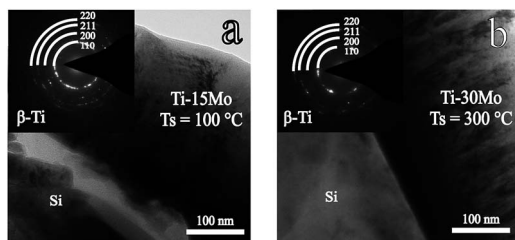


Fig. 2 The BF image and the SAED pattern of (a) the Ti–15 wt% Mo film at 100 °C and (b) the Ti–30 wt% Mo film at 300 °C.

metastable β -Ti phase is improved by increasing the content of isomorphous Mo element, and (ii) the substrate heating (T_s) does not supply enough activation energy for a phase change or the change is extremely sluggish. Fig. 1(d) displays the single $\beta(110)$ peaks at different T_s , showing right position shifts and broadenings as the T_s rises. The position shifts can be related to the change of lattice parameter due to alloying at different T_s . The Mo elements could not only incorporate in the β -Ti lattices, but also exist at the grain boundary in a state of amorphousness or very tiny crystallites. In the latter case, their qualities are so small that the diffraction intensity is below the detection limit. The atomic radius of Mo and Ti elements are 1.36 Å and 1.47 Å, respectively. As the T_s rises, the enhanced solid solution of those free Mo elements into the Ti matrix tends to decrease the lattice parameter of Ti matrix and right shift the peaks. The slight peak broadening with the T_s (Fig. 1(d)) is caused by the decreasing of the crystalline size which is attributed to impurity segregations. The impurity incorporations are hardly avoidable during real depositions. At higher T_s , the impurity segregations

to surfaces and grain boundaries could suppress crystalline growth of the fundamental structure.⁴⁰ Fig. 2(b) shows the BF image and corresponding SAED pattern of the β -Ti growth of the film at 300 °C, suggesting certain orientation growth at this temperature.

Besides the β phase growth, another important issue of these films is their morphology evolutions which particularly arise in the PVD process. Fig. 3 and 4 show the SEM results of surface and fracture morphologies of the Ti–15Mo and the Ti–30Mo alloy films, respectively, suggesting that the morphology evolution of the two films have some similarities with the increasing T_s . When the T_s ranges from 50 °C to 200 °C, they both present a relatively smooth surface morphology with small surface particles, and a columnar fracture morphology with distinct boundaries. When the T_s rises to 300 °C, the surface particles of two films both grow up greatly, leading to a coarse and roughness surface structure, and the surface and fracture morphologies both become dense at this temperature. Fig. 5 shows the AFM average surface roughness (R_a) of the two films both sharply rises at 300 °C, which is in accordance with the SEM observations.

One problem is that the Ti–15Mo alloy film can not keep the β -type growth above 100 °C. In spite of its β -type growth at 50 °C, Ti–15Mo alloy film shows a poor structure with voids and open boundaries, see Fig. 3(a), which is the microstructure of zone 1 in the low T_s range of the Movchan and Demchishin model.⁴¹ This poor structure is rather friable and not suitable for practical application, and the voids absorb impurities in the film interior which degrades the corrosion performance of the metallic film. Thus, it is necessary to improve the growth of Ti–15Mo alloy film deposited at 50 °C. According to the structure

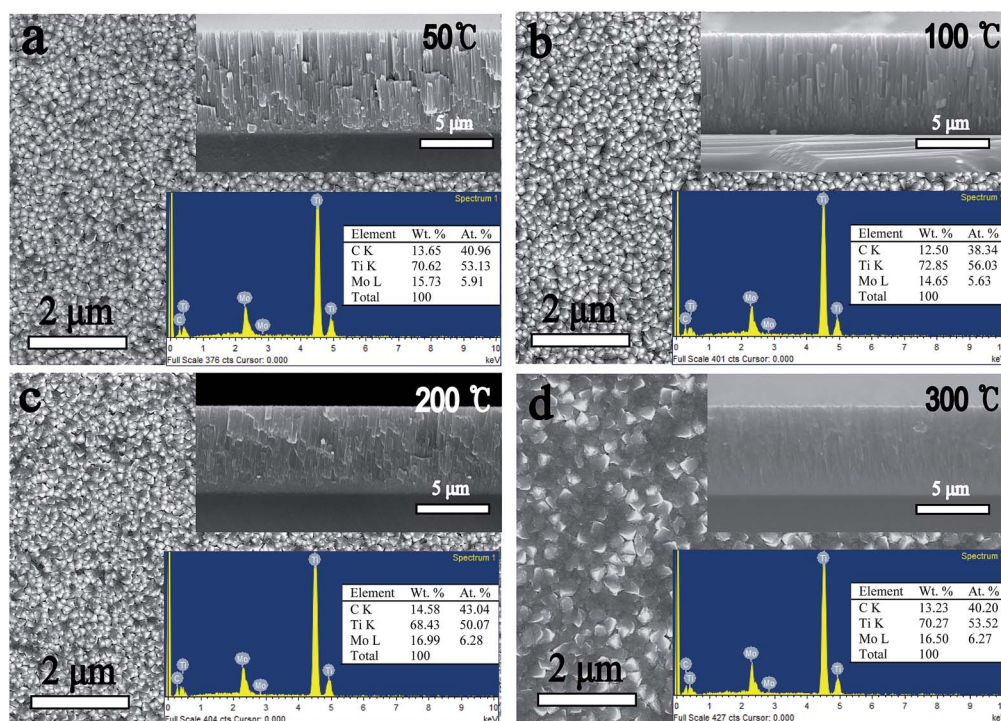


Fig. 3 The SEM surface and fracture images and the EDX results of the Ti–15 wt% Mo alloy films at different substrate temperature.



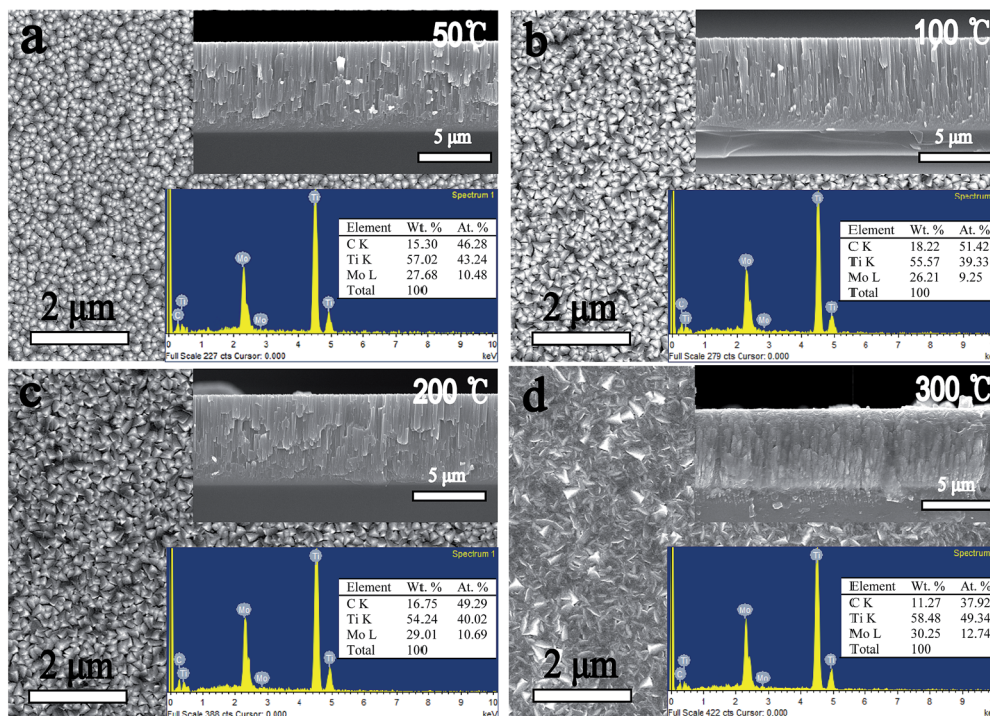


Fig. 4 The SEM surface and fracture images and the EDX results of the Ti-30 wt% Mo alloy films at different substrate temperature.

zone model (SZM) from Thornton,^{42,43} the zone 1 growth of the film can change into a dense and smooth non-columnar zone T growth at the low T_s range in assistance of the effect of particle bombardment. The principle of this low temperature sputtering of films with zone T growth is based on replacement of the equilibrium substrate heating by non-equilibrium atomic scale heating. Therefore, the poor structure of the Ti-15Mo film deposited at 50 °C can be improved without compromising its metastable β growth by enhancing the particle bombardment, such as decreasing the working pressure, rising the sputtering power, or using the substrate bias. Fig. 6 shows the fracture image of the Ti-15Mo alloy film deposited at 50 °C when the low working pressure 0.2 Pa and the substrate bias -100 V were used. The film structure is significantly improved because of the disappearance of voids and columnar growth mode, which can be defined as the microstructure of zone T in the SZM from Thornton.^{42,43}

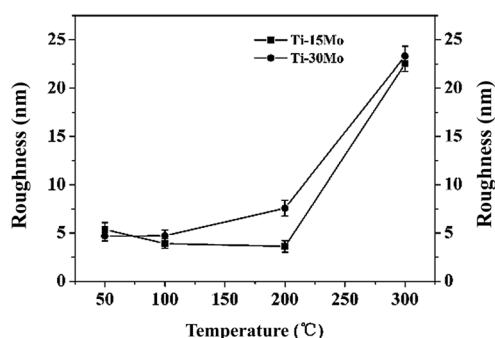


Fig. 5 The AFM surface roughness of the Ti-15 wt% Mo and Ti-30 wt% Mo films at different T_s , respectively.

When the T_s rises to 300 °C, the morphologies of two films become completely different, as shown in Fig. 3(d) and 4(d). The first difference is that the surface particles of the two films have completely different shape features at 300 °C. This can be related to the different phases of the two films at 300 °C. As a comparison, Zhang *et al.*⁴⁴ showed that the surface particles of β -type Ti-Cr alloy films have similar spherical shape features under their experimental conditions, with 10 at%, 25 at%, 40 at% Cr contents, respectively. The second difference is that the columnar fracture morphology of Ti-15Mo alloy film disappears, which is replaced by a smooth and noncolumnar one, while that of the Ti-30Mo alloy film keeps at 300 °C. The SZMs from Movchan and Demchishin⁴¹ and Thornton^{42,43} qualitatively represent the microstructure of single-phase films with the increasing T_s/T_m . These models, however, strongly change when impurities or additives are incorporated in the film.^{39,40}

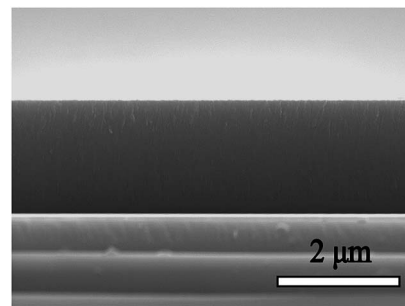


Fig. 6 The dense structure of Ti-15 wt% Mo alloy films deposited at 50 °C when the low working pressure (0.2 Pa) and the substrate bias (-100 V) were used, which is accordance with the zone T growth in the SZM.



This is because the impurities or additives may lead to the formation of a segregation layer^{40,45} or a new phase^{39,46} on the phase boundaries of the forming majority phase, which would change the growth mode of the films. In the present work, Ti-30Mo alloy films have a single phase in the whole T_s range, and the transition from a poor columnar growth to a dense columnar growth is consistent with the transition from zone 1 to zone 2 in the SZMs. However, it must be noted that the impurity incorporation or the co-deposited Mo elements have inevitably influenced the growth of the film during deposition, although the columnar mode of the film is sustained. For Ti-15Mo alloy films, the formation of new phase disturbs the columnar growth of the films, and leads to a structure with no distinct columnar growth. The similar results were found in Zr-Cu-N nanocomposite coatings.⁴⁷ At a low Cu content of 1–2 at%, the film exhibits a columnar growth, while at a high Cu content of 20 at%, Cu as an additive phase, which is detected by the XRD, can block the growth of all grains already in the coalescence stage and results in fine globular structure of the film. Barna *et al.*⁴⁶ investigated the microstructures of $Al_{1-x}Pt_x$ alloy films with $0 \leq x \leq 0.4$ using TEM, and found the formation of Al_5Pt and Al_6Pt intermetallic phases on the boundaries of Al islands. Equiaxial grains of the minority phase decorate grain boundaries and triple points, thus decrease migration of grain boundaries and grain coarsening.⁴⁸ These results all show that the formation of new phase can strongly affect the development

of the film structure. Therefore, Ti-15Mo and Ti-30Mo alloy films have different structural features at 300 °C.

The EDX and XPS techniques are used to acquire bulk and surface compositions of the two films, respectively. It is known that the EDX detection depth is up to several micrometers, while the XPS detection depth is only nanoscaled from the film surface. Typical EDX spectra and corresponding composition results of the Ti-15Mo and the Ti-30Mo alloy films at different substrate temperatures are inserted in Fig. 3 and 4, respectively. Besides major Ti and Mo peaks, C peaks are also detected by EDX. Fig. 7 provides the XPS survey spectra of the two films deposited at 100 °C and 300 °C, respectively, where the C and O peaks are both detected. These impurities in the films mainly come from two sources. The first is the adsorption of the residual gas of the vacuum system during deposition, which affects the crystalline growth and the texture evolution of the films,³⁹ or leads to the intrinsic compressive stress in the films.⁴⁹ The other is the adsorption of impurities when the films are exposed in the air after deposition. The C component is commonly from the adsorption of hydrocarbon molecules or C-containing gas molecules, and the O component is from the formation of metallic oxides and the adsorption of oxygen or oxygen-containing gas molecules.³⁴ Fig. 8 shows the typical XPS Ti 2p and Mo 3d spectra of the Ti-15Mo films deposited at 300 °C, respectively. Ti 2p spectra (Fig. 8(a)) are fitted by 4 components associated to metallic Ti, TiO , Ti_2O_3 , and TiO_2 , while only the TiO_2 component is pronounced for all films. Mo 3d spectra (Fig. 8(b)) are fitted by 3 components associated to Mo, MoO_2 , Mo_2O_5 . The MoO_2 component is more prominent for all films, although metallic component and Mo_2O_5 are also noticeable. These results show that the surfaces of the films are naturally oxidized in the air. These partially oxidized surface layers are desirable because they could provide great corrosion protection for implant materials.

The EDS and XPS alloy compositions for the two films at 100 °C and 300 °C are shown in Table 1, respectively, where the C and O components are excluded. The comparison between EDS and XPS results suggests an enrichment of Ti on the film surface. This type of composition diversity can be caused by two reasons. The first one is related to the different sputtering yields between Ti and Mo atoms. Ti-Mo alloy targets are used in this work. Ti and Mo atoms alternately denote the main species

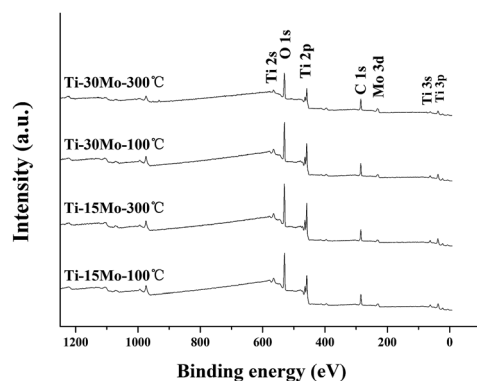


Fig. 7 The wide scan XPS spectra of the Ti-15 wt% Mo and Ti-30 wt% Mo alloy films deposited at 100 °C and 300 °C, respectively.

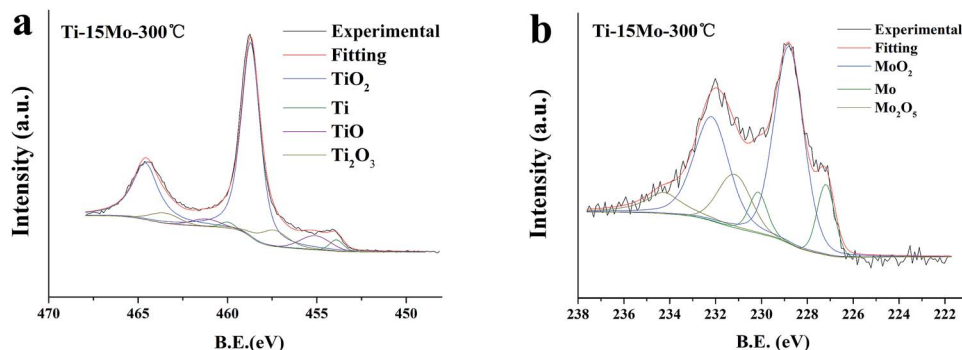


Fig. 8 The typical Ti 2p and Mo 3d spectra of Ti-15 wt% Mo films deposited at 300 °C, respectively.



Table 1 The EDS and XPS atomic percent (at%) of Ti element for the Ti–15% Mo and Ti–30% Mo alloy films at 100 °C and 300 °C, respectively. The C and O components have been excluded

Target composition	T_s	Ti/(Ti + Mo) (at%)	
		EDS	XPS
Ti–15% Mo	100 °C	90.39 ± 1.12	91.96 ± 1.11
	300 °C	89.53 ± 1.04	92.73 ± 1.87
Ti–30% Mo	100 °C	80.96 ± 1.51	86.18 ± 2.15
	300 °C	79.48 ± 0.77	83.85 ± 1.05

which are reflected from the surface of the target during deposition. Therefore, the composition of Ti and Mo atoms arriving on the growing surface of the film alternately changes during deposition, leading to a difference between the surface composition and the bulk composition of the films. The second reason is connected with the formation of surface oxidation layer of the films. The Ti enrichment in the surface oxidation layers has been found for Ti–13Nb–13Zr and Ti–50Zr alloys.⁵⁰ Recently, this result was also found for co-deposited Ti–Nb alloy films.³³ In this co-deposition process, pure Ti and pure Nb targets are operated at constant conditions, respectively. We can infer that, during the film thickening, the composition of the Ti and Nb atoms arriving on the growing surface of the film is constant, and the film have a uniform alloy composition from its growing surface to the internal. As a result, the Ti enrichment on the film surfaces can be attributed to the surface oxidation behaviours of the films after deposition.

4. Conclusions

Biomedical β -Ti alloy films prepared by magnetron sputtering received much attentions for the use as biomedical surface modifications layers. Controlling the β -Ti growth in the films is a focused issue, which is related to the deposition parameters and the alloy compositions of the films. Ti–15 wt% Mo and Ti–30 wt% Mo alloys are both popular β -Ti alloys, but their films formed by magnetron sputtering have not yet been studied. This paper investigates the sputter-deposited Ti–15 wt% Mo and Ti–30 wt% Mo alloy films when the substrate temperature is 50 °C, 100 °C, 200 °C and 300 °C, respectively. XRD results show that Ti–15 wt% Mo alloy films could keep a metastable β growth only at 50 °C and 100 °C, and the β -Ti growth at 100 °C is further confirmed by the SAED pattern. As a comparison, Ti–30 wt% Mo alloy films could keep a metastable β growth at a higher substrate temperature up to 300 °C, which is also confirmed by the SAED pattern. Besides the different phase formations, the two films exhibits different morphology evolutions as the substrate temperature rises. SEM observations show that the two films both have a zone 1 growth at the low substrate temperature range. When the substrate temperature rises to 300 °C, Ti–30 wt% Mo alloy films change into a dense and columnar zone 2 growth which is accordance with the SZMs, while Ti–15 wt% Mo alloy films change into a noncolumnar growth, which is considered to be connected with the formation of new phase in the films. AFM measurements indicate that

surface roughness of the two films both sharply increases at 300 °C. XPS analysis show a predominance of TiO₂ and MoO₂ in the surface oxide layers of the films. The comparison between the EDS and the XPS results shows an enrichment of Ti on the oxide surface layer for all films.

Conflicts of interest

There are no conflicts to declare.

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